



1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Gary M. Moore  
Assignee: Moore Epitaxial Inc.  
Title: METHOD OF CONTROLLING GAS FLOW TO A SEMICONDUCTOR  
PROCESSING REACTOR  
Serial No.: 09/765,919 Filed: January 18, 2001  
Examiner: Unknown Group Art 1763  
Unit:  
Docket No.: MTEC101001

Monterey, CA  
October 23, 2001

ASSISTANT COMMISSIONER FOR PATENTS  
Washington, D.C. 20231

RECEIVED  
JAN 15 2002  
TC 1700

INFORMATION DISCLOSURE STATEMENT  
UNDER §1.97(b)

Sir:

Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant wishes to call the following documents (a copy of each is enclosed) to the attention of the Examiner.

**U.S. PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	NAME
1)	6,126,753	10/03/00	Shinriki et al.
2)	5,728,222	03/17/98	Barbee et al.

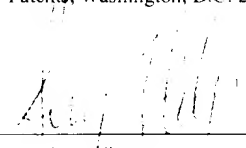
A PTO form 1449 listing these documents is enclosed.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, other than as described above; or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).


If the U.S.P.T.O. issued a first office action prior to the mailing date of this paper, the Commissioner is hereby authorized to charge any fees required for consideration of this Information Disclosure Statement, and to credit any overpayment of fees to Deposit Account No. 50-0553.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on October 23, 2001.

  
\_\_\_\_\_  
Attorney for Applicant(s)

October 23, 2001  
Date of Signature

Respectfully submitted,

  
Serge J. Hodgson  
Attorney for Applicant(s)  
Reg. No. 40,017  
(831) 655-0880